

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang et al.

Application No. 10/036,332

Filed: Dec 24, 2001

For: CARBON NANOTUBE-  
CONTAINING STRUCTURES,  
METHODS OF MAKING, AND  
PROCESSES USING SAME

Art Unit: 1724

Examiner: R. Hopkins

Atty Docket: 12860-E-CIP

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 CFR §§ 1.56 and 1.97-1.99, the documents listed on the attached Form(s) PTO-1449 are being brought to the attention of the Examiner in charge of the above-identified application.

No item of information contained in this information disclosure statement was known to any individual designated in § 1.56(c) more than three months prior to the filing of this information disclosure statement. This is because, although the parent application had been filed in 2001, the cited patent issued less than 3 months ago. Therefore, it is believed that no fees are due; however, if any fees are required for consideration of this Information Disclosure Statement, please charge such fees to Deposit Account No. 50-1749.

The Examiner is respectfully requested to initial the space adjacent each document entry on the Form(s) PTO-1449, and to return a copy of the initialled Form(s) PTO-1449 to confirm that the documents have been considered and have been officially made of record in this application.

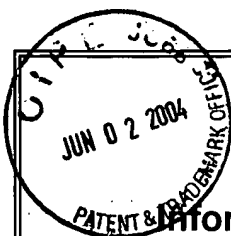
If the Examiner has any questions or wishes to discuss this application, the Examiner is invited to telephone the undersigned representative at the number set forth below.

Respectfully submitted,

Date: 27 May 2004

By: Frank S. Rosenberg

Frank S. Rosenberg  
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## Form PTO-1449

## Information Disclosure Citation

Attorney Docket  
12860E-CIPApplication No.  
10/036,332Applicant  
Wang et al.Filing Date  
Dec. 24, 2001Group Art Unit  
1724

## U.S. Patent Documents

Examiner Initial		Patent Number	Date	Name	Class	Sub-Class	Filing Date
	AA	6,713,519	Mar 2004	Wang et al.	518	715	12/21/2001
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

## Foreign Patent Documents

		Document Number	Date	Country	Class	Sub-Class	Translation
	AI						Yes No

## Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

	AJ	
	AK	
	AL	
	AM	
	AN	
	AO	
	AP	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.